

OLIFF & BERRIDGE, PLC

ATTORNEYS AT LAW

Application Data Sheet

Application Information

Application Type:: Regular
Subject Matter:: Utility
CD-ROM or CD-R: None
Title:: METHOD OF FABRICATING SEMICONDUCTOR
DEVICE
Attorney Docket Number:: 116434
Suggested Drawing Figure::
Total Drawing Sheets:: 18 (Figs. 1-18)
Small Entity:: No

Applicant Information

Applicant Authority type:: Inventor
Primary Citizenship Country:: Japan
Status:: Full Capacity
Given Name:: Susumu
Middle Name::
Family Name:: INOUE
Name Suffix::
City of Residence:: Suwa-shi
State or Province of Residence:: Nagano-ken
Country of Residence:: Japan

Correspondence Information

Correspondence Customer Number:: 25944

Foreign Priority Information			
Country::	Application Number::	Filing Date::	Priority Claimed::

Japan	2002-204274	07/12/02	Yes
Assignee Information			
Assignee Name::		Seiko Epson Corporation	
Street of mailing address::		4-1, Nishi-shinjuku 2-chome	
		Shinjuku-ku	
City of mailing address::		Tokyo	
State or Province of mailing address::			
Country of mailing address::		Japan	
Postal or Zip Code of mailing address::			